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L'historiographie du Concile Vatican II accorde une place limitée au monde des religieux. Ce constat a guidé le projet du colloque international réuni à Rome en 2014 à l'initiative du LARHRA pour proposer une approche globale et évaluer les variables liées à la diversité des familles religieuses, des contextes sociaux ou ecclésiaux et des réalités nationales ou transnationales. En se centrant sur l'Europe occidentale et l'Amérique du Nord et en croisant les études de cas, il a permis de mieux saisir la place de l'événement conciliaire dans les dynamiques de changement à l'œuvre dans les décennies 1950, 1960 et 1970.

2. Record Nr.	UNINA9910367563703321
Autore	Zimmermann André
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Sommario/riassunto	Micro manufacturing involves dealing with the fabrication of structures in the size range of 0.1 to 1000 µm. The scope of nano manufacturing extends the size range of manufactured features to even smaller length scales-below 100 nm. A strict borderline between micro and nano manufacturing can hardly be drawn, such that both domains are treated as complementary and mutually beneficial within a closely interconnected scientific community. Both micro and nano manufacturing can be considered as important enablers for high-end products. This Special Issue of Applied Sciences is dedicated to recent advances in research and development within the field of micro and nano manufacturing. The included papers report recent findings and advances in manufacturing technologies for producing products with micro and nano scale features and structures as well as applications underpinned by the advances in these technologies.